HIGHLY EFFICIENT LOW CARBON FOOTPRINT SOLAR CELLS: IMPACT OF HIGH TEMPERATURE PROCESSING ON EPITAXIALLY GROWN P-TYPE SILICON WAFERS



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PorSi

Substrate

EpiWafer

Concept of epitaxially grown

wafers with reusable substrate.

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Introduction

- Epitaxially grown wafers ,EpiWafers' with a low carbon-footprint and low costs are suited for highly efficient solar cells
- Cell efficiencies above 25 % predicted for
 TOPCoRE solar cells on p-type Si EpiWafers¹
- Remaining quality limitation of EpiWafers are structural defects

We investigate the influence of high temperature treatment during TOPCoRE solar cell fabrication on the material quality of EpiWafers focusing on structural defects.

Material quality of EpiWafers after high temperature treatment

EpiWafers

- Epitaxially deposited in an APCVD batch reactor of microelectronic standard
- **3** Ωcm p-type Si, 5x5 cm², 135 µm thick, KOH etched, Al₂O₃ passivated



Dislocations detected as etch pits (EP)

- Appear randomly distributed at the <u>front side</u>
- Arrange in lines along <110> and form pairs at the <u>back side</u>





EP distribution on as-grown EpiWafer's front side (left) and back side (right).

Microscope image ofIdea forEPs at the back side.with p

of Idea for dislocation model e. with pairwise connected EPs.³

Quality of EpiWafer after KOH etching

 Testing the effect of solely KOH etching in comparison to high temperature treatment and KOH etching

20 µm



High temperature treatment representing TOCoRE cell fabrication²

Oxidation at 1050°C for 1h (+ 3 min KOH etching)
 DOCL Cattering at 0.10°C for 1h (+ 5 min KOH etching)

POCl₃-Gettering at 840°C for 1h (+ 5 min KOH etching)

Material quality accessed by

- Photoluminescence imaging with lifetime calibration by modulated photoluminescence (modulum at Fraunhofer ISE)
- Efficiency limiting bulk recombination analysis (ELBA)
- μ PL-mapping with a high resolution of ~ 20 μ m



Lifetime images of the initial EpiWafer (left), after oxidation (middle) and after subsequent gettering (right) detected at an illumination of 0.05 sun eqs illumination.

Predicted solar cell efficiency η calculated by ELBA based on injection dependent PLI. The TOPCoRE solar cell efficiency limit is 26.6 % considering only intrinsic recombination.

	Initial EpiWafer	After Oxidation	After Gettering
η / %	20.7	22.0	23.8
$\eta_{ ext{Best}}$ / %	21.2	22.6	24.4

Lifetime images of the initial EpiWafer (left), after 3 min (middle) and after 8 min of KOH etching (right) detected at an illumination of 0.05 sun eqs. Illumination.

- KOH etching removes structural defects at the back side and hence improves material quality significantly
- The positive effect observed for the oxidation may mostly be due to the KOH etching
- Gettering has a positive influence on the material quality in direct comparison to KOH etching

Results







µPL-maps of the initial EpiWafer (left) and after oxidation and after subsequent gettering (right) unveil a drastic change in structural defects: from a line-wise orientation to a random distribution.

- EpiWafers are well suited for high temperature treatment during high-efficiency solar cell fabrication
- In the initial EpiWafer, quality limiting structural defects are mainly located on the backside
- Structural defects at the backside can be removed by KOH etching
- POCl₃-gettering has an extremely positive effect on the material quality with predicted solar cell efficiencies exceeding 24 %



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Poster content will be published as a Solar RRL research article soon!

